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**Baek et al.**

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(54) **METHODS RELATED TO PREPARATION OF A STENCIL TO RECEIVE A PLURALITY OF IC UNITS**

(58) **Field of Classification Search**

CPC ..... H01L 21/67336; H01L 21/6835; H01L 24/14; H01L 22/10; H01L 2221/68354; H01L 2224/1412; H01L 2221/68313; H01L 2221/68309; H01L 22/12; H01L 21/67333

See application file for complete search history.

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(57) **ABSTRACT**

A method for preparing a stencil to receive a plurality of IC units, the method comprising the steps of: providing a metal substrate having an array of apertures; applying an adhesive surface to said substrate; removing portions of said adhesive surface corresponding to the apertures in the metal substrate.

(52) **U.S. Cl.**

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**6 Claims, 11 Drawing Sheets**

